

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Ichio YUDASAKA, Tatsuya SHIMODA, Sadao KANBE and Wakao MIYAZAWA

Application No.: New Rule 1.53(b) Divisional of U.S.S.N. 09/325,567

Filed: July 10, 2001

Docket No.: 040090.02

For: THIN FILM DEVICE PROVIDED WITH COATING FILM, LIQUID CRYSTAL
PANEL AND ELECTRONIC DEVICE, AND METHOD FOR MAKING THE THIN
FILM DEVICE

PRELIMINARY AMENDMENT

Director of the U.S. Patent and Trademark Office
Washington, D. C. 20231

Sir:

Prior to initial examination, please amend the above-identified application as follows:

IN THE CLAIMS:

Please cancel claims 1-59 without prejudice to or disclaimer of the subject matter
contained therein.

Please add new claims 60-110 as follows:

--60. A process for forming a pattern on a substrate by deposition of an organic
material comprising the steps of:

depositing a semiconducting organic material in a solvent onto a substrate by
ink-jet printing; and

evaporating the solvent, whereby said organic material remains on the
substrate.--